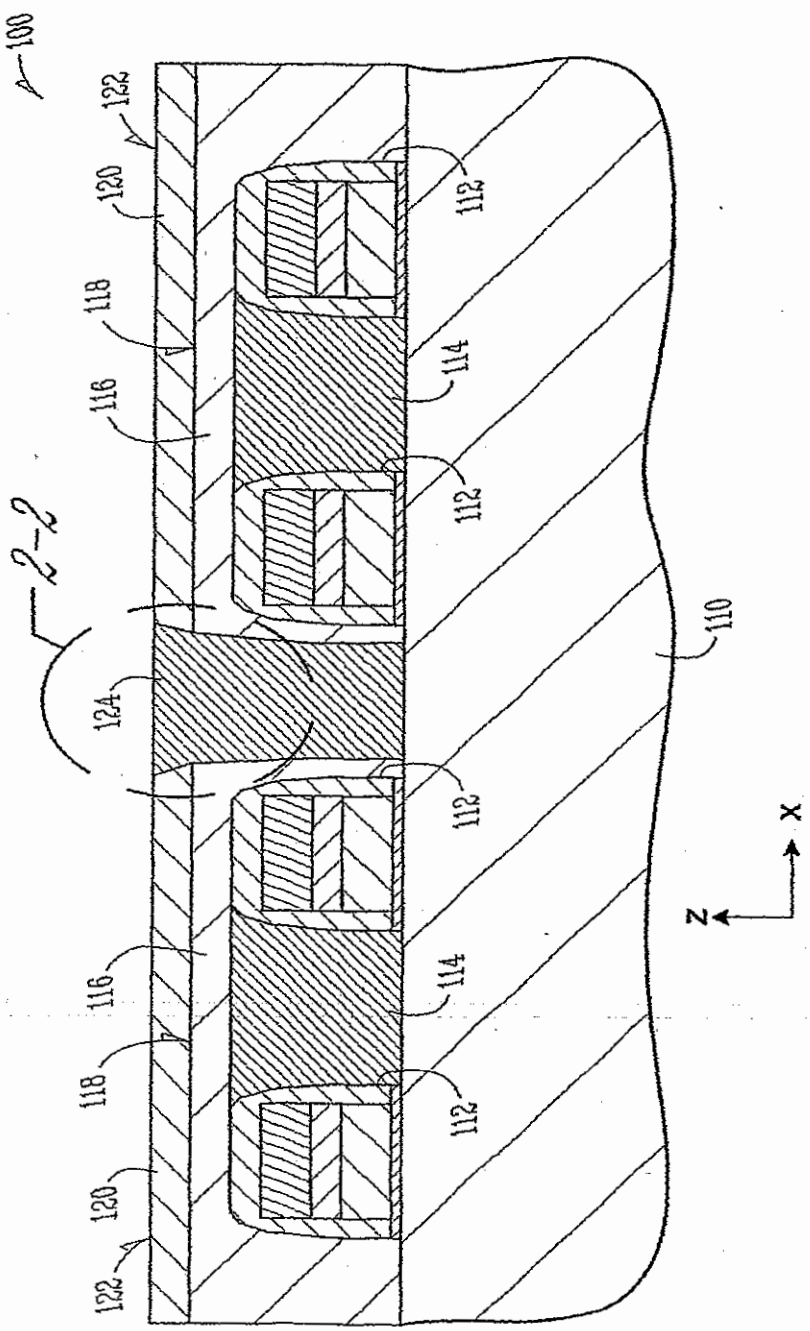


Fig. 1

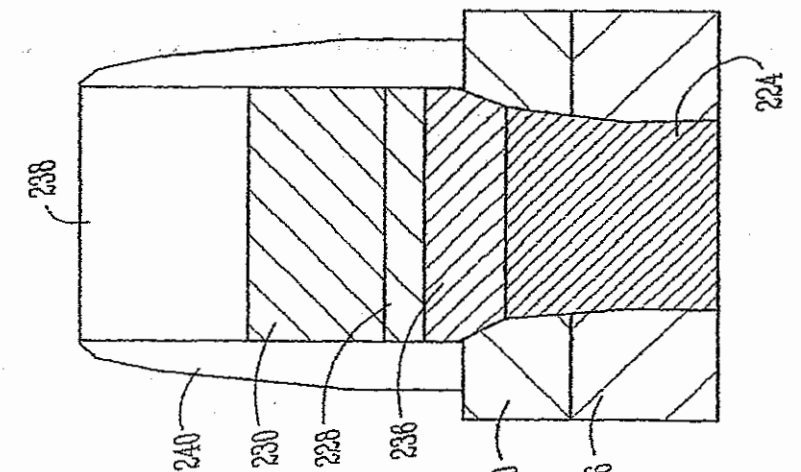


Fig.2C

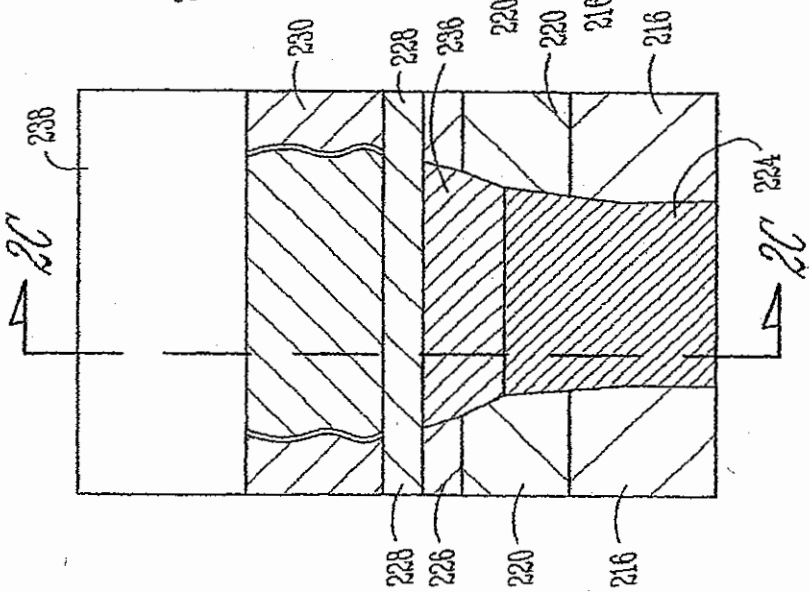


Fig.2B

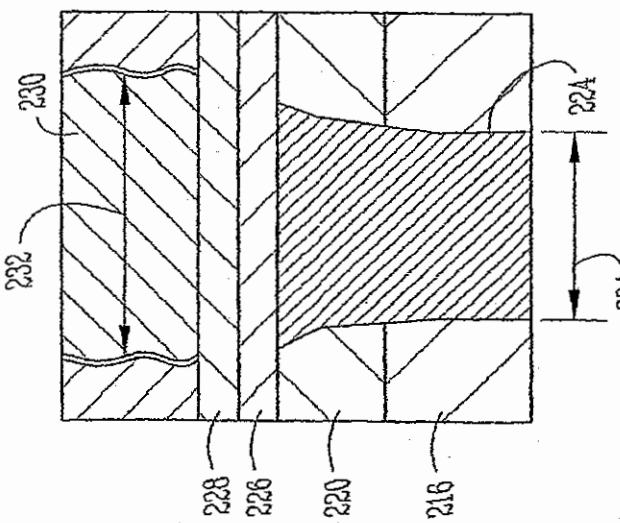


Fig.2A

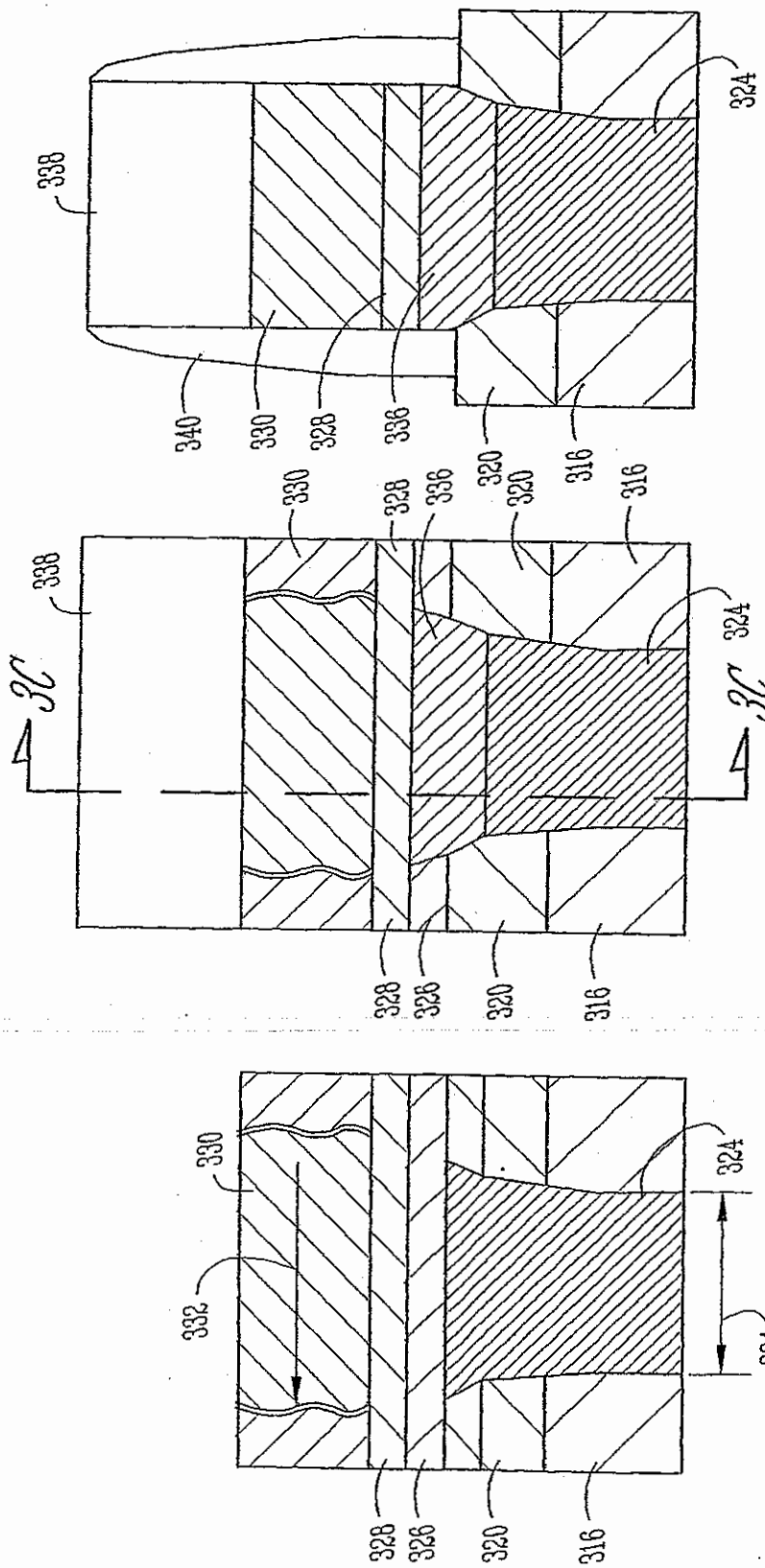


Fig. 3C

Fig. 3B

Fig. 3A

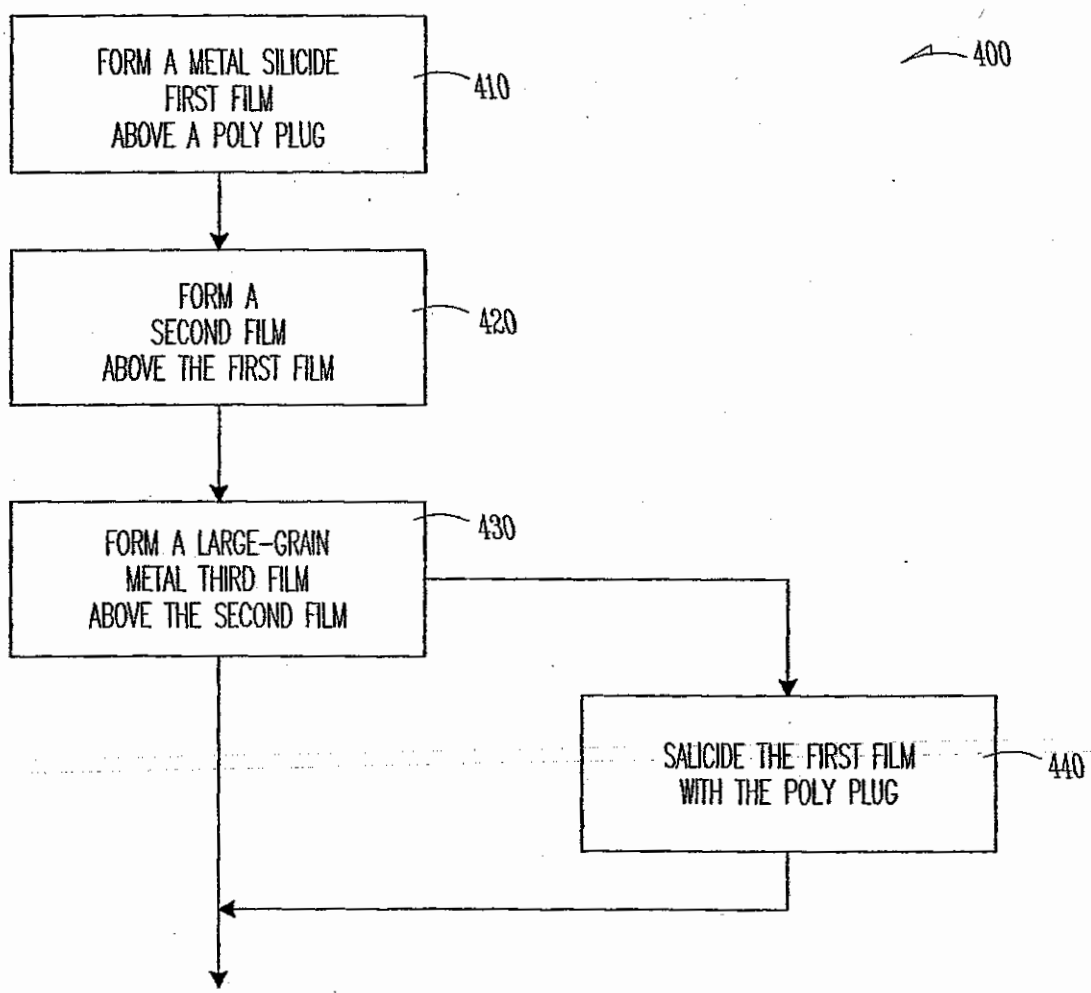

FORM A METAL SILICIDE FIRST FILM ABOVE A POLY PLUG
410
400
FORM A SECOND FILM ABOVE THE FIRST FILM
420
FORM A LARGE-GRAIN METAL THIRD FILM ABOVE THE SECOND FILM
430
SALICIDE THE FIRST FILM WITH THE POLY PLUG
440

Fig. 4

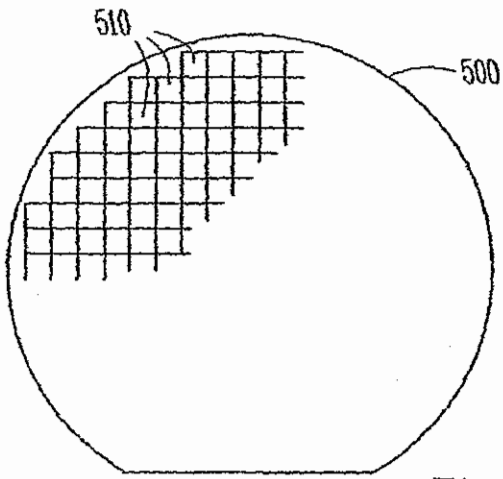


Fig. 5

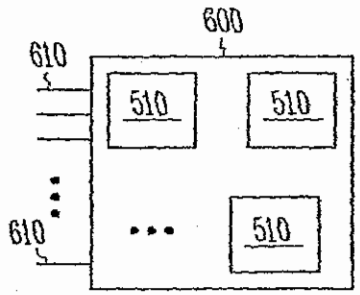


Fig. 6

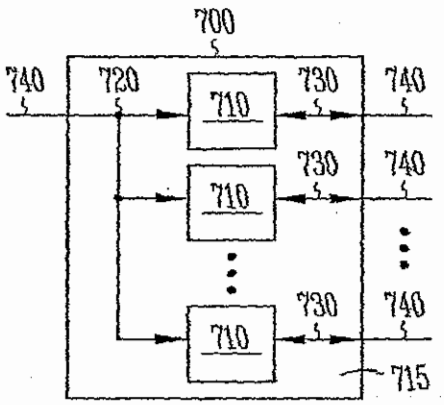


Fig. 7

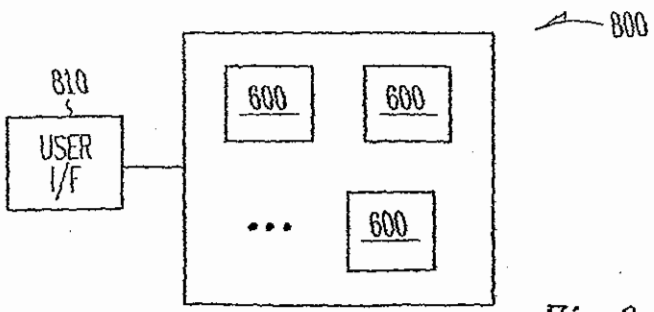


Fig. 8

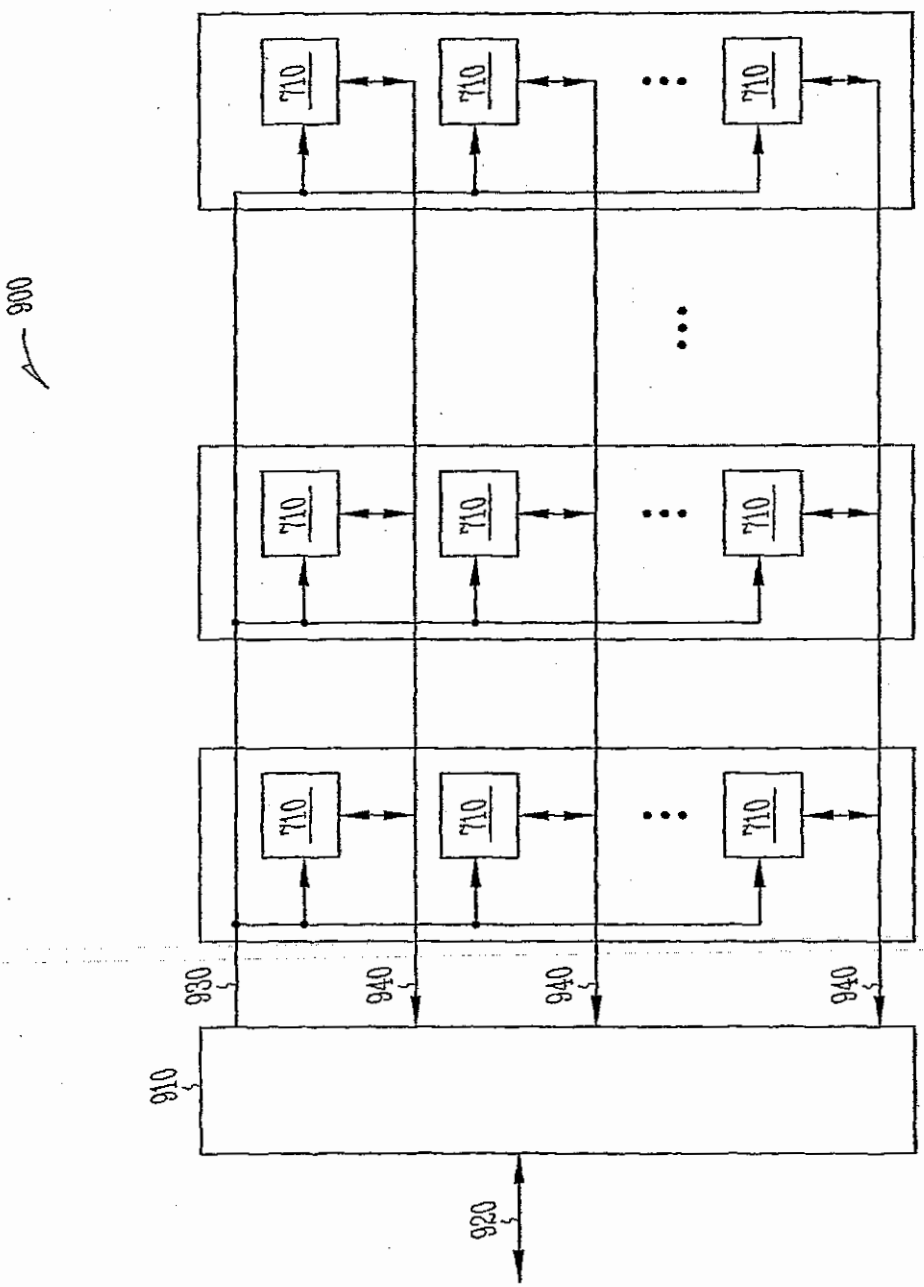


Fig. 9

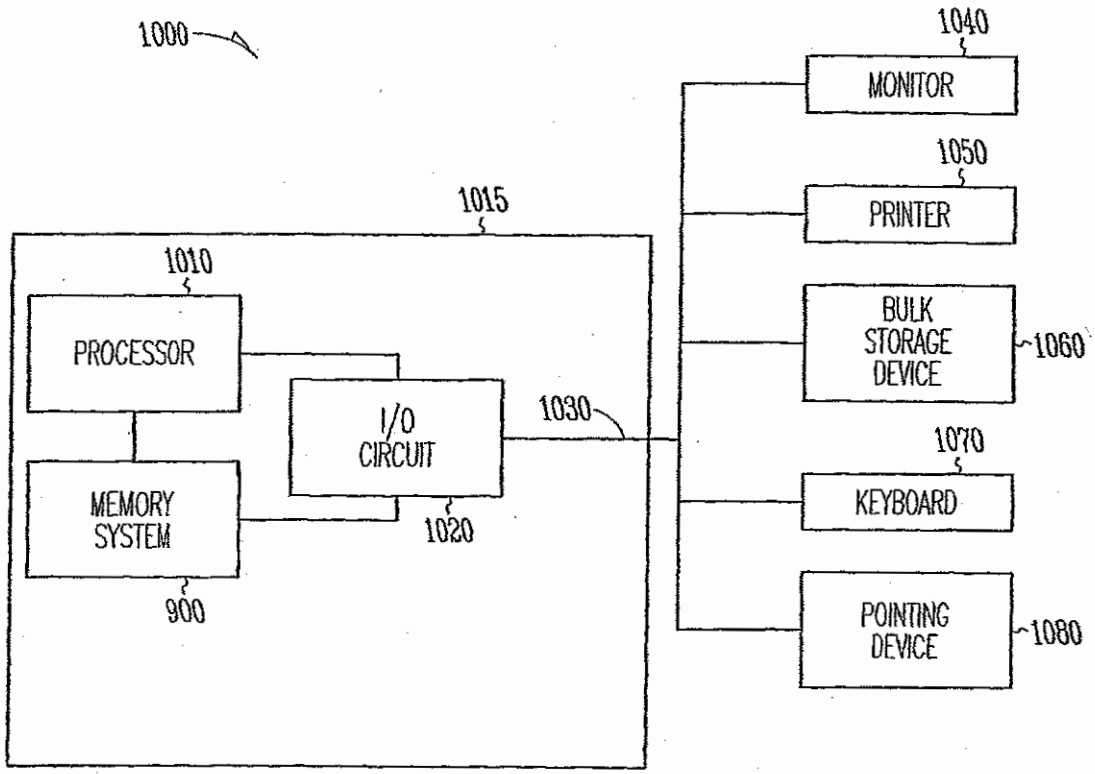

1000
1040
MONITOR
1050
PRINTER
1015
1010
PROCESSOR
BULK STORAGE DEVICE
1060
1030
I/O CIRCUIT
1070
KEYBOARD
MEMORY SYSTEM
1020
900
POINTING DEVICE
1080

Fig. 10